

**Notice of References Cited**

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Applicant(s)/Patent Under  
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CWALINA ET AL.

Examiner

Qing Chen

Art Unit

2191

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0233236 A1	11-2004	Yang, Dennis Woojun	345/763
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
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**FOREIGN PATENT DOCUMENTS**

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	N					
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